



**ELECTRONIC COPY**

## LABORATORY GROWN DIAMOND REPORT

December 25, 2025	
IGI Report Number	LG760513283
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUT CORNERED RECTANGULAR MODIFIED BRILLIANT
Measurements	10.13 X 7.22 X 4.92 MM

## GRADING RESULTS

Carat Weight	3.04 CARATS
Color Grade	G
Clarity Grade	VS 2

### ADDITIONAL GRADING INFORMATION

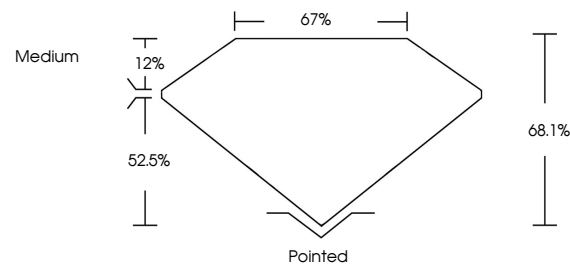
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE

Inscription(s)  LG760513283

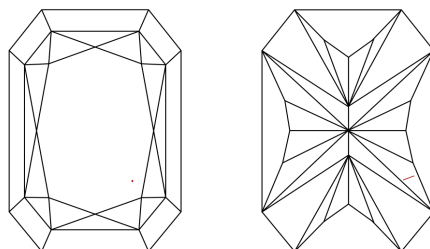
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

LG760513283  
Report verification at [lgi.org](https://lgi.org)

## PROPORTIONS

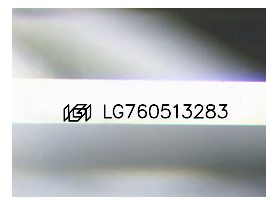


## CLARITY CHARACTERISTICS



### KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.



Sample Image Used

## COLOR

D E F G H I J Faint Very Light Light

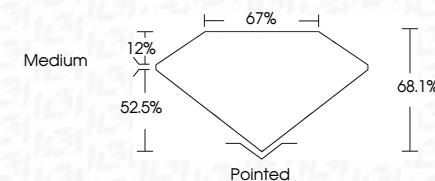
## CLARITY

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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